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**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**

(use as many sheets as necessary)

Sheet 1 of 1 Attorney Docket Number 286697-00005

## **U.S. PATENT DOCUMENTS**

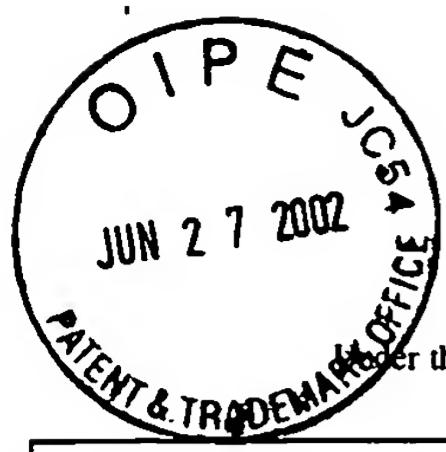
## **FOREIGN PATENT DOCUMENTS**

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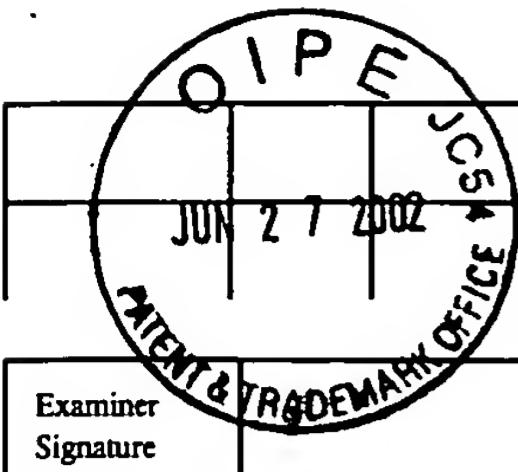
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Substitute for form 1449B/PTO				Complete if Known	
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>				Application Number	10/086,025
				Filing Date	February 28, 2002
				First Named Inventor	Marc R. Anderson
				Group Art Unit	1743
				Examiner Name	<i>JUL 3 - 2002</i>
Sheet	1	of	1	Attorney Docket Number	286697-10005 <i>TC 1700</i>

Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
* <i>AS</i>		FASSETT et al., <i>Determination of Nanogram Quantities of Vanadium in Biological Material by Isotope Dilution Thermal Ionization Mass Spectrometry with Ion Counting Detection</i> , Anal. Chem. (November 1985), pp. 2474-2478, V57, No. 13.	
* <i>AS</i>		FASSETT et al., <i>Isotope Dilution Mass Spectrometry for Accurate Elemental Analysis</i> , Anal. Chem. (May 15, 1989), pp. 643A-649A V61, No. 10.	
* <i>AS</i>		<i>VIEZIAN</i> VIEZIAN et al., <i>On-line Isotope Dilution and Sample Dilution by Flow Injection and Inductively Coupled Plasma Mass Spectrometry</i> , J. Anal. Atom. Spectro. (April 1990), pp. 125-133, V5.	
* <i>AS</i>		ROTTMANN et al., <i>Determination of Heavy Metal Interactions with Dissolved Organic Materials in Natural Aquatic Systems by Coupling a High-Performance Liquid Chromatography System with an Inductively Coupled Plasma Mass Spectrometer</i> , Anal. Chem. (November 1, 1994), pp. 3709-3715, V66.	
* <i>AS</i>		HEUMANN et al., <i>Elemental Speciation with Liquid Chromatography-Inductively Coupled Plasma Isotope Dilution Mass Spectrometry</i> , J. Anal. Atom. Spectro. (December 1994), pp. 1351-1355 V9.	
* <i>AS</i>		HORN et al., <i>Comparison of heavy metal analyses in hydrofluoric acid used in microelectronic industry by ICP-MS and thermal ionization isotope dilution mass spectrometry</i> , Fresenius J. Anal. Chem. (1994), pp. 286-292, V350.	
* <i>AS</i>		ROTTMANN et al., <i>Development of an on-line isotope dilution technique with HPLC/ICP-MS for the accurate determination of elemental species</i> , Fresenius J. Anal. Chem. (1994), pp. 221-227, V350.	
* <i>AS</i>		COLE, <i>Electrospray Ionization Mass Spectrometry: Fundamentals, Instrumentation and Applications</i> , John Wiley & Sons, Inc. (1997), New York.	
* <i>AS</i>		STEWART, <i>Electrospray mass spectrometry: a tool for elemental speciation</i> , Spectrochimica, Acta. (1999), pp. 1649-1695, Part-B, Vol. 54.	
* <i>AS</i>		<i>International Technology Roadmap for Semiconductors 1999 Edition: Defect Reduction</i> , Sematech, Austin, TX, pp. 269-293.	
* <i>AS</i>		NEWTON et al., <i>Analysis of Copper Plating Baths - Suppressors and Levelers</i> , Electrochemical Society Proceedings, pp. 1-5, V2000-27.	

*Allen Soderquist* 6/25/03



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